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## APPLICANTS

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## \*\* CONTINUING DATA

None BT

## \*\* FOREIGN APPLICATIONS

None B1

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 01/29/2002

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no					
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowable Drawn					
Verified and Acknowledged	<u>John W. Tram</u> Examiner's Signature	Initials	STATE OR COUNTRY NM	SHEETS DRAWING 1	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 2

## ADDRESS

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## TITLE

Selective etchant for oxide sacrificial material in semiconductor device fabrication

FILING FEE RECEIVED 740	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other <input type="checkbox"/> Credit
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